



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Peter de Groot et al.

Art Unit

: Unknown

Serial No.: 10/795,808

Examiner: Unknown

Filed

: March 8, 2004

Title

: PROFILING COMPLEX SURFACE STRUCTURES USING SCANNING

INTERFEROMETRY

Commissioner for Patents P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050, referencing Attorney Docket No. 09712-341001.

Respectfully submitted,

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*See attached document certifying that Marc M. Wefers has limited recognition to practice before the U.S. Patent and Trademark Office under 37 C.F.R. § 10.9(b).

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CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

March 31, 2004 Date of Deposit Signature

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Sheet	1	of	2	

	O (Superiore Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 09712-341001	Application No.
	APR 0 2 2004 proformation Disclosure Sta	plicant	Applicant Peter de Groot et al.	
REEL	(Use several sho	eets if necessary)	Filing Date March 8, 2004	Group Art Unit

	U.S. Patent Documents						
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	4,576,479	03/18/1986	Downs	356	351	
	AB	4,999,014	03/12/1991	Gold et al.	356	382	
	AC	5,133,601	07/28/1992	Cohen et al.	356	359	
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	AF	6,597,460	07/22/2003	Groot et al.	356	512	
	AG						
	AH						

	Foreign Patent Documents or Published Foreign Patent Applications							
Examiner	Desig.	Document	Publication	Country or	·		Trans	lation
Initial	ID	Number	Date	Patent Office	Class	Subclass	Yes	No
	AI	0 397 388 A2	11/14/1990	EPO	G01B	11/06		
	AJ	0 549 166 A2	06/30/1993	EPO	G01B	11/06		
	AK							
	AL							

	Other Documents (include Author, Title, Date, and Place of Publication)				
Examiner	Desig.				
Initial	ID	Document			
	AM	Dresel, Thomas et al., "Three-dimensional sensing of rough surfaces by coherence radar", Applied Optics, Vol. 31, No. 7, pp. 919-925 (March 1, 1992)			
	AN	Feke, Gilbert D. et al., "Interferometric back focal plane microellipsometry", <u>Applied Optics</u> , Vol. 37, No. 10, pp. 1796-1802 (April 1, 1998)			
	AO	Kim, Seung-Woo et al., "Thickness-profile measurement of transparent thin-film layers by white-light scanning interferometry", <u>Applied Optics</u> , Vol. 38, No. 28, pp. 5968-5973 (October 1,1999)			
·	AP	Kino, Gordon S. et al., "Mirau correlation microscope", <u>Applied Optics</u> , Vol. 29, No. 26, pp. 3775-3783 (September 10, 1990)			
	AQ	Pelligrand, S. et al., "Mesures 3D de topographies et de vibrations a l'echelle (sub)micrometrique par microscopie optique interferometrique", <u>Proc. Club CMOI, Methodes et Techniques Optiques pour l'Industrie</u> (2002)			
	AR	Pluta, Maksymilian, "Advanced Light Microscopy", Vol. 3, (Elsevier, Amsterdam, 1993) pp. 265-271			
t.	AS	Rosencwaig, Allan et al., "Beam profile reflectometry: A new technique for dielectric film measurements", Applied Physics Letters, Vol. 60, No. 11, pp. 1301-1303 (March 16, 1992)			

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if no	it in conformance and not considered. Include copy of this form with
next communication to applicant	

Sheet	_2_	of	2	

Substitute orm PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 09712-341001	Application No.
MIN O Z ZOO, - I hy A	sclosure Statement applicant	Applicant Peter de Groot et al.	
(Use several s	heets if necessary)	Filing Date March 8, 2004	Group Art Unit

(Other Documents (include Author, Title, Date, and Place of Publication)				
Examiner Initial	Desig. ID	Document			
	BA	Sandoz, Patrick "Wavelet transform as a processing tool in white-light interferometry", Optics Letters, Vol. 22, No. 14, pp. 1065-1067 (July 15, 1997)			
	ВВ	Shatalin, S.V. et al., "Reflection conoscopy and micro-ellipsometry of isotropic thin film structures", Journal of Microscopy, Vol. 179, Part 3, pp. 241-252 (September, 1995)			
	вс				
	BD				

Examiner Signature Date Considered

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